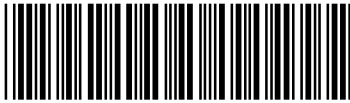


Search Notes

Application/Control No.

10/633,928

Examiner

Sylvia R. MacArthur

Applicant(s)/Patent under
Reexamination

MAKI, KEIGO

Art Unit

1792

SEARCHED

Class	Subclass	Date	Examiner
118	724	11/8/2009	SRM
118	725	11/8/2009	SRM
156	345.52	11/8/2009	SRM
156	345.53	11/8/2009	SRM
118	728	11/8/2009	SEM

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
118	724	11/8/2009	SRM
118	725	11/8/2009	SRM
156	345.52	11/8/2009	SRM
156/345.53 118/728		11/8/2009	SRM

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
updated search	11/5/2009	SRM
discussed app with PHassanzadeh	10/29/2009	SRM
allowance conference with PHassanzadeh	11/5/2009	SRM